

*“Degrees
Ahead in
Quality”*



The Model OG-120 is a desk top size purification furnace designed to supply purified Inert Gases (Argon, Helium, Neon, Xenon and Krypton) for smaller demands or for laboratory needs.



The Model OG-120 is a self contained gas purification furnace, designed and manufactured by OXY-GON INDUSTRIES, INC., to purify inert gases to 10^{-6} PPM (parts per million) of Oxygen or better. In addition to removing Oxygen, the OG-120 purifier also removes Nitrogen, Carbon and Water Vapor. By installing a special cartridge, the oxygen content of Nitrogen can be purged to 10^{-6} PPM or better. The unit is designed to allow fast, easy replacement of the cartridge through a convenient front panel access door. Each cartridge can supply as much as 180,000 cubic feet of purified gas when used with standard industrial gas containing oxygen as high as 10 PPM.

MODEL OG-120 SPECIFICATIONS:

Electrical Requirements.....	120V, 1 Phase, 50/60 Hz
Gettered Gas Purity.....	less than 10 ⁻⁶ PPM of Oxygen
Argon Gas Flow.....	60 LPM (128 CFH)
Helium Gas Flow.....	180 LPM (380 CFH)
Maximum Pressure.....	616 KPA (90 PSIG)
Getter Charge.....	180 grams (0.4 lb)
Power Consumption.....	1600 watts
Outgoing Gas Temperature.....	Slightly above ambient
External Cabinet Size.....	21" W x 10" H x 20 1/8" D
Weight.....	20.4 KG (45 lbs)
Rack Mounting.....	Std. 19" EIA x 8 3/4" High

PRICING:

Consult Factory

OPTIONS:

Iron charge and regeneration kit for purifying nitrogen. Forming gas (95%N₂/5%H₂) is required for regeneration cycle.



For a comprehensive review of your specific requirements, please contact OXY-GON'S technical sales personnel for a customized proposal with specifications.

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